

The documentation and process conversion measures necessary to comply with this revision shall be completed by 10 November 1999.

INCH-POUND

MIL-PRF-19500/523B
10 August 1999
SUPERSEDING
MIL-S-19500/523A
21 July 1993

PERFORMANCE SPECIFICATION SHEET

SEMICONDUCTOR DEVICE, DARLINGTON TRANSISTOR, NPN, SILICON, POWER
TYPES 2N6383, 2N6384, 2N6385, JAN, JANTX, AND JANTXV

This specification is approved for use by all Departments and Agencies of the Department of Defense.

1. SCOPE

1.1 Scope. This specification covers the performance requirements for NPN, silicon, power transistors. Three levels of product assurance are provided for each device type as specified in MIL-PRF-19500.

1.2 Physical dimensions. See figure 1 (TO-3).

1.3 Maximum ratings.

	P_T 1/ $T_A = +25^\circ\text{C}$	P_T 2/ $T_C = +25^\circ\text{C}$	V_{CBO}	V_{CEO}	V_{EBO}	I_C	I_B	T_{OP} and T_{STG}	$R_{\theta JC}$ Max
	<u>W</u>	<u>W</u>	<u>V dc</u>	<u>V dc</u>	<u>V dc</u>	<u>A dc</u>	<u>A dc</u>	<u>°C</u>	<u>°C/W</u>
2N6383	6.0	100	40	40	5.0	10	0.25	-55 to +175	1.75
2N6384	6.0	100	60	60	5.0	10	0.25	-55 to +175	1.75
2N6385	6.0	100	80	80	5.0	10	0.25	-55 to +175	1.75

1/ Derate linearly 34.2 mW/°C above $T_A > +25^\circ\text{C}$.

2/ Derate linearly 571 mW/°C above $T_C > +25^\circ\text{C}$.

1.4 Primary electrical characteristics.

	h_{FE1}	$V_{CE(SAT)1}$	$V_{CE(SAT)2}$	$V_{BE(ON)1}$	C_{obo}	$ h_{fe} $	Switching	
	$V_{CE} = 3.0 \text{ V dc}$ $I_C = 5.0 \text{ A dc}$ 1/	$I_C = 5.0 \text{ A dc}$ $I_B = 10 \text{ mA dc}$ 1/	$I_C = 10 \text{ A dc}$ $I_B = 0.1 \text{ A dc}$ 1/	$V_{CE} = 3.0 \text{ V dc}$ $I_C = 5.0 \text{ A dc}$ 1/	$V_{CB} = 10 \text{ V dc}$ $I_E = 0$ $100 \text{ kHz} < f \leq 1 \text{ MHz}$	$V_{CE} = 5.0 \text{ V dc}$ $I_C = 1.0 \text{ A dc}$ $f = 1 \text{ MHz}$	$V_{CC} = 30 \text{ V dc}$ $I_{CC} = 5.0 \text{ A dc}$ $I_{B1} = 20 \text{ mA dc}$	
		<u>V dc</u>	<u>V dc</u>	<u>V dc</u>	<u>pF</u>		<u>t_{on}</u>	<u>t_{off}</u>
Min	1,000					20		
Max	20,000	2.0	3.0	2.8	200	300	2.5	10.0

1/ Pulsed, see 4.5.1

Beneficial comments (recommendations, additions, deletions) and any pertinent data which may be of use in improving this document should be addressed to: Commander, Defense Supply Center Columbus, ATTN: DSCC-VAC, 3990 East Broad Street, Columbus, OH 43216-5000, by using the Standardization Document Improvement Proposal (DD Form 1426) appearing at the end of this document or by letter.

2. APPLICABLE DOCUMENTS

2.1 General. The documents listed in this section are specified in sections 3 and 4 of this specification. This section does not include documents cited in other sections of this specification or recommended for additional information or as examples. While every effort has been made to ensure the completeness of this list, document users are cautioned that they must meet all specified requirements documents cited in sections 3 and 4 of this specification, whether or not they are listed.

2.2 Government documents.

2.2.1 Specifications, standards, and handbooks. The following specifications, standards, and handbooks form a part of this document to the extent specified herein. Unless otherwise specified, the issues of these documents are those listed in the issue of the Department of Defense Index of Specifications and Standards (DODISS) and supplement thereto, cited in the solicitation (see 6.2).

SPECIFICATION

DEPARTMENT OF DEFENSE

MIL-PRF-19500 - Semiconductor Devices, General Specification for.

STANDARD

MILITARY

MIL-STD-750 - Test Methods for Semiconductor Devices.

(Unless otherwise indicated, copies of the above specifications, standards, and handbooks are available from the Defense Automated Printing Service, Building 4D (DPM-DODSSP), 700 Robbins Avenue, Philadelphia, PA 19111-5094.)

3. REQUIREMENTS

3.1 Qualification. Devices furnished under this specification shall be products that are authorized by the qualifying activity for listing on the applicable qualified manufacturer's list before contract award (see 4.2 and 6.3).

3.2 Associated specification. The individual item requirements shall be in accordance with MIL-PRF-19500 and as specified herein.

3.3 Abbreviations, symbols, and definitions. Abbreviations, symbols, and definitions used herein shall be as specified in MIL-PRF-19500.

3.4 Interface requirements and physical dimensions. The interface requirements and physical dimensions shall be as specified in MIL-PRF-19500 and on figure 1 herein. The preferred measurements used herein are the metric units. However, this transistor was designed using inch-pound units of measurement. In case of conflicts between the metric and inch-pound units, the inch-pound units shall rule.

3.4.1 Lead finish. Lead finish shall be solderable in accordance with MIL-STD-750, MIL-PRF-19500, and herein. Where a choice of lead finish or formation is desired, it shall be specified in the acquisition requirements (see 6.2)

3.5 Marking. Marking shall be in accordance with MIL-PRF-19500.

3.6 Electrical performance characteristics. Unless otherwise specified, the electrical performance characteristics are as specified in 1.3, 1.4, and table I herein.

3.7 Electrical test requirements. The electrical requirements shall be the subgroups specified in table I herein.

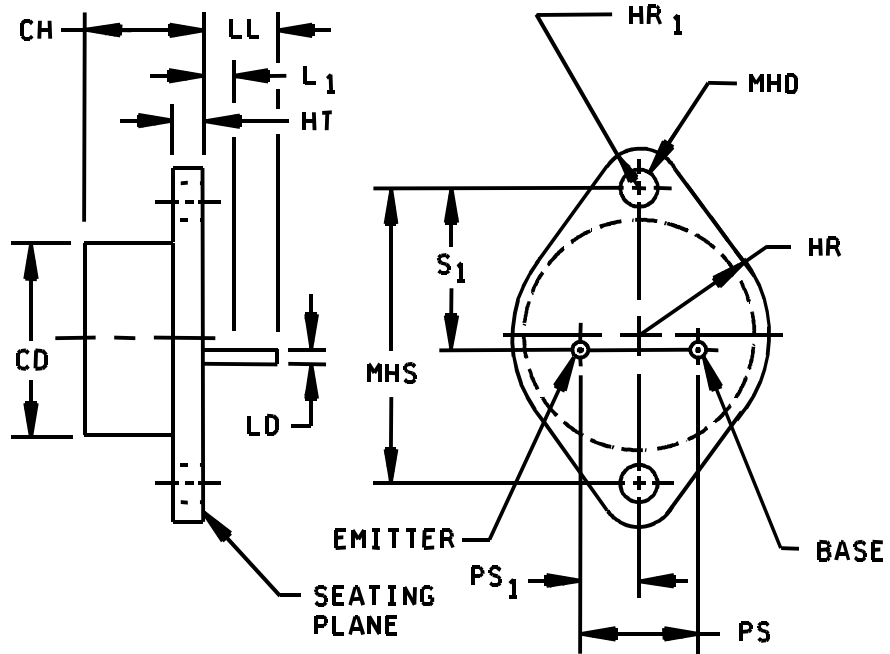


FIGURE 1. Dimensions and configuration (T0-3).

Symbol	Dimensions				Notes
	Inches		Millimeters		
	Min	Max	Min	Max	
CD		0.875		22.23	
CH	0.250	0.450	6.35	11.43	
HR	0.495	0.525	12.57	13.34	
HR ₁	0.131	0.188	3.33	4.78	
HT	0.050	0.135	1.27	3.43	
LD	0.038	0.043	0.97	1.09	
LL	0.312		7.92		
L ₁		0.050		1.27	
MHD	0.151	0.161	3.84	4.09	
MHS	1.177	1.197	29.90	30.40	
PS	0.420	0.440	10.67	11.18	3
PS ₁	0.205	0.225	5.21	5.72	3
s ₁	0.655	0.675	16.64	17.15	

NOTES:

1. Dimensions are in inches.
2. Metric equivalents are given for general information only.
3. These dimensions should be measured at points 0.050 inch (1.27 mm) and 0.055 inch (1.40 mm) below seating plane. When gauge is not used measurement will be made at the seating plane.
4. The seating plane of the header shall be flat within 0.001 inch (0.03 mm) concave to 0.004 inch (0.10 mm) convex inside a 0.930 inch (23.62 mm) diameter circle on the center of the header and flat within 0.001 inch (0.03 mm) concave to 0.006 inch (0.15 mm) convex overall.
5. Mounting holes shall be deburred on the seating plane side.
6. Collector is electrically connected to the case.

FIGURE 1. Dimensions and configuration (T0-3) continued.

4. VERIFICATION

4.1 Classification of inspections. The inspection requirements specified herein are classified as follows:

- a. Qualification inspection (see 4.2).
- b. Screening (see 4.3)
- c. Conformance inspection (see 4.4).

4.2 Qualification inspection. Qualification inspection shall be in accordance with MIL-PRF-19500.

4.3 Screening (JANTX and JANTXV levels only). Screening shall be in accordance with table IV of MIL-PRF-19500, and as specified herein. The following measurements shall be made in accordance with table I herein. Devices that exceed the limits of table I herein shall not be acceptable.

Screen (see table IV of MIL-PRF-19500)	Measurement
	JANTX and JANTXV levels only
11	I_{CEX1} and h_{FE1}
12	See 4.3.1
13	ΔI_{CEX1} = 100 percent of initial value or 100 μ A dc, whichever is greater; Δh_{FE1} = $\pm$ 25 percent of initial value; subgroup 2 of table I herein.

4.3.1 Power burn-in conditions. Power burn-in conditions are as follows:

$$T_J = +162.5^\circ\text{C} \pm 12.5^\circ\text{C};$$

$$2N6383 = V_{CB} = 30 \text{ V dc}; 2N6384 = V_{CB} = 40 \text{ V dc}; 2N6385 = V_{CB} = 60 \text{ V dc}.$$

4.4 Conformance inspection. Conformance inspection shall be in accordance with MIL-PRF-19500.

4.4.1 Group A inspection. Group A inspection shall be conducted in accordance with MIL-PRF-19500 and table I herein. Electrical measurements (end-points) shall be in accordance with table I, subgroup 2 herein.

4.4.2 Group B inspection. Group B inspection shall be conducted in accordance with the conditions specified for subgroup testing in table VIb (JAN, JANTX, and JANTXV) of MIL-PRF-19500, and as follows. Electrical measurements (end-points) shall be in accordance with table I, subgroup 2 herein.

4.4.2.1 Group B inspection, table VIb of MIL-PRF-19500.

<u>Subgroup</u>	<u>Method</u>	<u>Condition</u>
B3	1027	For solder die attach: $V_{CB} \geq 10 \text{ V dc}$, 2,000 cycles, $T_A \leq 35^\circ\text{C}$.
B3	1026	For eutectic die attach: $V_{CB} \geq 10 \text{ V dc}$, $T_A \leq 35^\circ\text{C}$ adjust P_T to achieve $T_J = 150^\circ\text{C}$ minimum.
B5	3131	$V_{CE} = 20 \text{ V dc}$; $I_C = 10 \text{ A}$; $R_{\theta JC} = 1.75^\circ\text{C/W}$ maximum.

4.4.3 Group C inspection. Group C inspection shall be conducted in accordance with the conditions specified for subgroup testing in table VII of MIL-PRF-19500, and as follows. Electrical measurements (end points) shall be in accordance with table I, subgroup 2 herein.

4.4.3.1 Group C inspection, table VII of MIL-PRF-19500.

<u>Subgroup</u>	<u>Method</u>	<u>Condition</u>
C2	2036	Test condition A; weight = 10 pounds; t = 15 s.
C6	1027	For solder die attach: $V_{CB} \geq 10$ V dc, 6,000 cycles, $T_A \leq 35^\circ\text{C}$.
C6	1026	For eutectic die attach: $V_{CB} \geq 10$ V dc, $T_A \leq 35^\circ\text{C}$ adjust P_T to achieve $T_J = 150^\circ\text{C}$ minimum.

4.5 Methods of inspection. Methods of inspection shall be as specified in the appropriate tables and as follows.

4.5.1 Pulse measurements. Conditions for pulse measurements shall be as specified in section 4 of MIL-STD-750.

TABLE I. Group A inspection.

Inspection <u>1</u> /	MIL-STD-750		Symbol	Limits		Unit
	Method	Conditions		Min	Max	
<u>Subgroup 1</u>						
Visual and mechanical Examination	2071					
<u>Subgroup 2</u>						
Collector to emitter breakdown voltage	3011	Bias condition D $I_C = 200 \text{ mA dc}$, Pulsed (see 4.5.1)	$V_{(BR)CEO}$			
2N6383				40		V dc
2N6384				60		V dc
2N6385				80		V dc
Collector to emitter breakdown voltage	3011	Bias condition B $I_C = 200 \text{ mA dc}$ $R_{BB} = 100\Omega$, Pulsed (see 4.5.1)	$V_{(BR)CER}$			
2N6383				40		V dc
2N6384				60		V dc
2N6385				80		V dc
Collector to emitter cutoff current	3041	Bias condition D	I_{CEO}		1.0	mA dc
2N6383		$V_{CE} = 40 \text{ V dc}$				
2N6384		$V_{CE} = 60 \text{ V dc}$				
2N6385		$V_{CE} = 80 \text{ V dc}$				
Emitter to base cutoff current	3061	Bias condition D $V_{EB} = 5.0 \text{ V dc}$	I_{EBO}		5.0	mA dc
Collector to emitter cutoff current	3041	Bias condition A $V_{BE} = 1.5 \text{ V dc}$	I_{CEX1}		0.3	mA dc
2N6383		$V_{CE} = 40 \text{ V dc}$				
2N6384		$V_{CE} = 60 \text{ V dc}$				
2N6385		$V_{CE} = 80 \text{ V dc}$				
Collector to base cutoff current	3036	Bias condition D	I_{CBO1}		1.0	mA dc
2N6383		$V_{CE} = 40 \text{ V dc}$				
2N6384		$V_{CE} = 60 \text{ V dc}$				
2N6385		$V_{CE} = 80 \text{ V dc}$				

See footnote at end of table.

TABLE I. Group A inspection - Continued.

Inspection <u>1</u> /	MIL-STD-750		Symbol	Limits		Unit
	Method	Conditions		Min	Max	
<u>Subgroup 2</u> – Continued						
Base emitter voltage (unsaturated)	3066	Test condition B $V_{CE} = 3.0 \text{ V dc}$, $I_C = 5.0 \text{ A dc}$	$V_{BE(on)1}$		2.8	V dc
Base emitter voltage (unsaturated)	3066	Test condition B $V_{CE} = 3.0 \text{ V dc}$, $I_C = 10 \text{ A dc}$ pulsed (see 4.5.1)	$V_{BE(on)2}$		4.5	V dc
Saturated voltage and resistance	3071	$I_C = 5.0 \text{ A dc}$ $I_B = 10 \text{ mA dc}$, pulsed (see 4.5.1)	$V_{CE(sat)1}$		2.0	V dc
Saturated voltage and resistance	3071	$I_C = 10 \text{ A dc}$ $I_B = 0.1 \text{ A dc}$, pulsed (see 4.5.1)	$V_{CE(sat)2}$		3.0	V dc
Forward-current transfer ratio	3076	$V_{CE} = 3 \text{ V dc}$ $I_C = 5 \text{ A dc}$; pulsed (see 4.5.1)	h_{FE1}	1,000	20,000	
Forward current transfer ratio	3076	$V_{CE} = 3.0 \text{ V dc}$ $I_C = 10 \text{ A dc}$, pulsed (see 4.5.1)	h_{FE2}	100		
<u>Subgroup 3</u>						
High temperature operation:		$T_A = +150^{\circ}\text{C}$				
Collector to emitter cutoff current	3041	Bias condition A $V_{BE} = 1.5 \text{ V dc}$	I_{CEX2}		3.0	mA dc
2N6383 2N6384 2N6385		$V_{CE} = 40 \text{ V dc}$ $V_{CE} = 60 \text{ V dc}$ $V_{CE} = 80 \text{ V dc}$				
Low temperature operation:		$T_A = -55^{\circ}\text{C}$				
Forward-current transfer ratio	3076	$V_{CE} = 3.0 \text{ V dc}$ $I_C = 5.0 \text{ A dc}$, pulsed (see 4.5.1)	h_{FE3}	200		

See footnote at end of table.

TABLE I. Group A inspection - Continued.

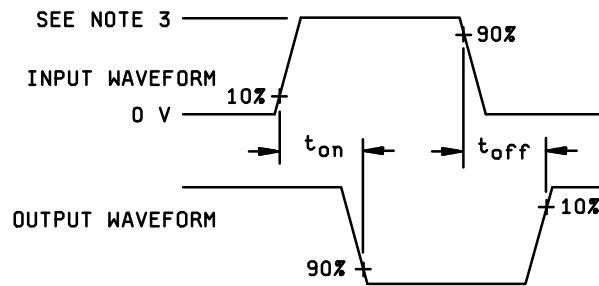
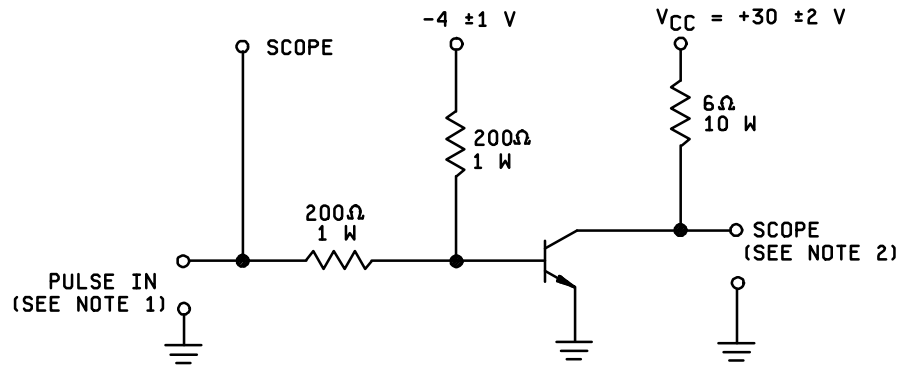
Inspection <u>1</u> /	MIL-STD-750		Symbol	Limits		Unit
	Method	Conditions		Min	Max	
<u>Subgroup 4</u>						
Pulse response	3251	Test condition A, except test circuit and pulse requirements in accordance with figure 2				
Turn-on time		$V_{CC} = 30 \text{ V dc}$ $I_C = 5.0 \text{ A dc}$ $I_{B1} = 20 \text{ mA dc}$	t_{on}		2.5	μs
Turn-off time		$V_{CC} = 30 \text{ V dc}$ $I_C = 5.0 \text{ A dc}$ $I_{B1} = - I_{B2} = 20 \text{ mA dc}$	t_{off}		10	μs
Small-signal short-circuit forward-current transfer ratio	3306	$V_{CE} = 5 \text{ V dc}$ $I_C = 1 \text{ A dc}$ $f = 1.0 \text{ MHz}$	$ h_{fe} $	20	300	
Open circuit output Capacitance	3236	$V_{CB} = 10 \text{ V dc}; I_E = 0$ $100 \text{ kHz} \leq f \leq 1 \text{ MHz}$	C_{obo}		200	pF
<u>Subgroup 5</u>						
Safe operating area (continuous dc)	3053	$T_C = +25^\circ\text{C}; t = 1.0 \text{ s, 1 cycle}$ See figure 3				
<u>Test 1</u> (Both device types)		$V_{CE} = 10 \text{ V dc}; I_C = 10 \text{ A dc}$				
<u>Test 2</u> (All device types)		$V_{CE} = 30 \text{ V dc}; I_C = 3.33 \text{ A dc}$				
<u>Test 3</u>						
2N6383		$V_{CE} = 40 \text{ V dc}; I_C = 1.5 \text{ A dc}$				
2N6384		$V_{CE} = 60 \text{ V dc}; I_C = 0.4 \text{ A dc}$				
2N6385		$V_{CE} = 80 \text{ V dc}; I_C = 0.16 \text{ A dc}$				

See footnote at end of table.

TABLE I. Group A inspection - Continued.

Inspection <u>1</u> /	MIL-STD-750		Symbo l	Limits		Unit
	Method	Conditions		Min	Max	
<u>Subgroup 5</u> – Continued						
Electrical measurements		See table II, steps 1 and 3				
Safe operating area (switching)	3053	Load condition C (unclamped inductive load) See figure 4 $T_C = 25^\circ\text{C}$, duty cycle ≤ 10 percent $R_S = 0.1\Omega$				
<u>Test 1</u>		t_p approximately 1 ms (vary to obtain I_C) $R_{BB1} = 1\text{ k}\Omega$; $V_{BB1} = 10\text{ V dc}$; $R_{BB2} = \infty$; $V_{BB2} = 0\text{ V}$; $V_{CC} = 30\text{ V dc}$; $I_C = 10\text{ A dc}$; $R_L \leq 0.5\Omega$; $L = 1\text{ mH}$ at 10 A dc				
Electrical measurements		See table I, Subgroup 2.				
<u>Test 2</u>		t_p approximately 1 ms (vary to obtain I_C) $R_{BB1} = 10\text{ K}\Omega$; $V_{BB1} = 10\text{ V dc}$; $R_{BB2} = \infty$; $V_{BB2} = 0\text{ V}$; $V_{CC} = 30\text{ V dc}$; $I_C = 0.2\text{ A dc}$; $L = 100\text{ mH}$ at 0.2 A dc ; $R_L \leq 0.5\Omega$				
Safe operating area (switching)		Load condition B (clamped inductive load) See figure 5. $T_A = 25^\circ\text{C}$, $t_r + t_f \leq 1.0\text{ }\mu\text{s}$, duty cycle ≤ 10 percent; t_p $= 5\text{ ms}$ (vary to obtain I_C) $R_s = 0.1\text{ }\Omega$; V_{CC} $= 10\text{ V dc}$; $I_C = 10\text{ A dc}$				
2N6383		Clamp voltage = 40 V dc				
2N6384		Clamp voltage = 60 V dc				
2N6385		Clamp voltage = 80 V dc				
		Device fails if clamp voltage is not reached				
Electrical measurements		See table I, subgroup 2				

1/ For sampling plan, see MIL-PRF-19500.



NOTES:

1. The rise time (t_r) and fall time (t_f) of the applied pulse shall be each < 20 nanoseconds; duty cycle < 2 percent, generator source impedance shall be 50Ω; pulse width = 20 μs.
2. Output sampling oscilloscope: $Z_{IN} > 100 \text{ k}\Omega$; $C_{IN} < 50 \text{ pF}$; rise time < 2 nanoseconds.
3. Pulse In shall be 10 V maximum.

FIGURE 2. Pulse response test circuit.

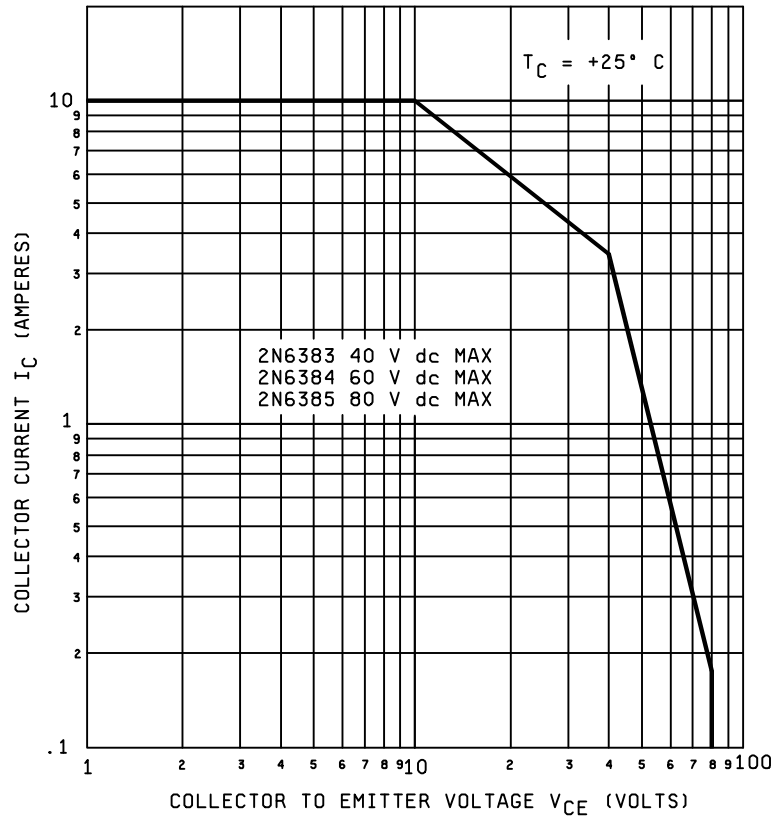


FIGURE 3. Maximum safe operating graph (continuous dc).

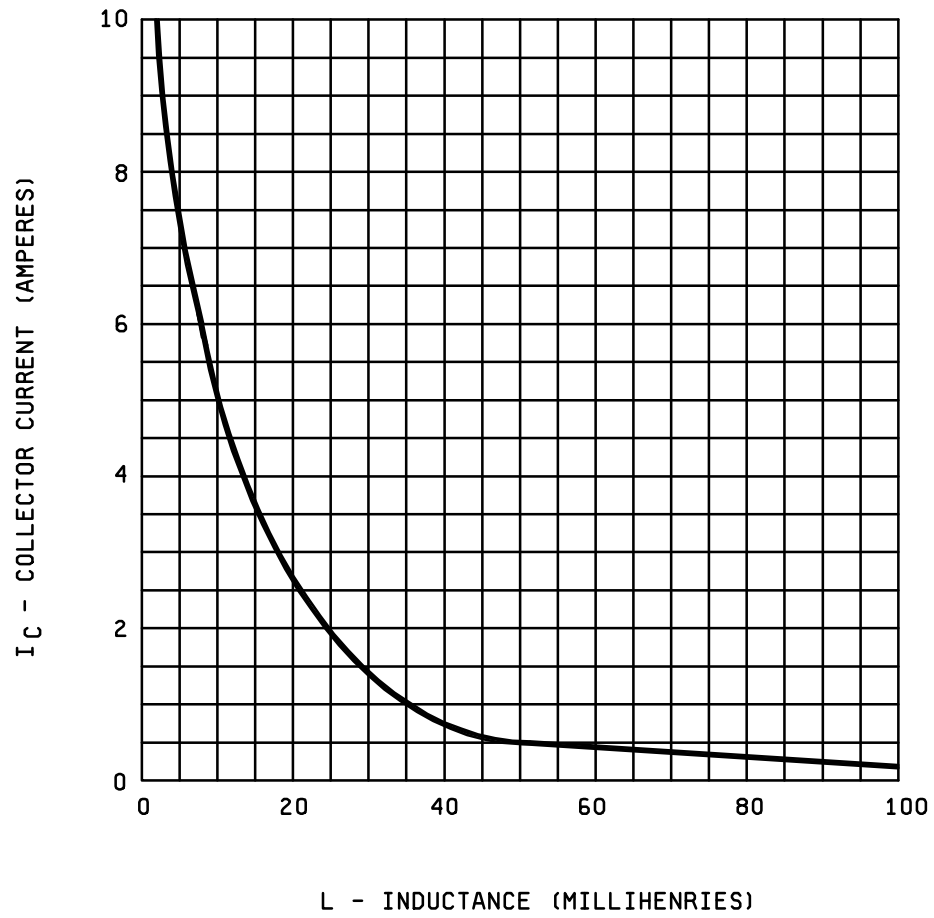
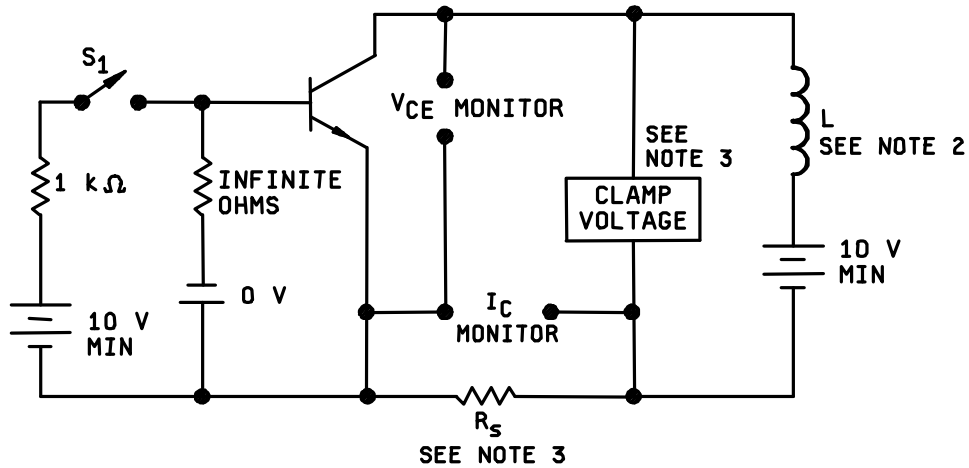


FIGURE 4. Safe operating area for switching between saturation and cutoff (unclamped inductive load).



NOTES:

1. Either a clamping circuit or clamping diode may be used.
2. The coil used shall provide a minimum inductance of 1 mH at 10 A with a max dc resistance of 0.1 ohm.
3. $R_S \leq 0.1 \text{ ohm}$. 12 W, 1 percent tolerance max (noninductive).
4. With switch S1 closed, set the specified test conditions.
5. Open S1. Device fails if clamp voltage is not reached and maintained until the current returns to zero.
6. Perform specified end point tests.

FIGURE 5. Clamped inductive sweep test circuit.

5. PACKAGING

5.1 Packaging. Packaging shall prevent mechanical damage of the devices during shipping and handling and shall not be detrimental to the device. When actual packaging of material is to be performed by DoD personnel, these personnel need to contact the responsible packaging activity to ascertain requisite packaging requirements. Packaging requirements are maintained by the Inventory Control Points' packaging activity within the Military Department or Defense Agency, or within the Military Departments' System Command. Packaging data retrieval is available from the managing Military Departments' or Defense Agency's automated packaging files, CD-ROM products, or by contacting the responsible packaging activity.

6. NOTES

(This section contains information of a general or explanatory nature that may be helpful, but is not mandatory.)

6.1 Notes. The notes specified in MIL-PRF-19500 are applicable to this specification.

6.2 Acquisition requirements. Acquisition documents must specify the following:

- a. Issue of DODISS to be cited in the solicitation (see 2.2.1).
- b. The lead finish as specified (see 3.4.1).
- c. Type designation and quality assurance level.
- d. Packaging requirements (see 5.1).

6.3 Qualification. With respect to products requiring qualification, awards will be made only for products which are, at the time of award of contract, qualified for inclusion in Qualified Manufacturer's List QML No.19500 whether or not such products have actually been so listed by that date. The attention of the contractors is called to these requirements, and manufacturers are urged to arrange to have the products that they propose to offer to the Federal Government tested for qualification in order that they may be eligible to be awarded contracts or purchase orders for the products covered by this specification. Information pertaining to qualification of products may be obtained from Defense Supply Center Columbus, ATTN: DSCC-VQE, 3990 East Broad Street, Columbus, OH 43216-5000.

6.4 Changes from previous issue. Marginal notations are not used in this revision to identify changes with respect to the previous issue due to the extent of the changes.

Custodian:
Army - CR
Navy - EC
Air Force - 11
NASA - NA
DLA - CC

Preparing activity:
DLA - CC

Review activities:
Air Force - 13, 19

(Project 5961-2074)

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1. The preparing activity must complete blocks 1, 2, 3, and 8. In block 1, both the document number and revision letter should be given.
2. The submitter of this form must complete blocks 4, 5, 6, and 7.
3. The preparing activity must provide a reply within 30 days from receipt of the form.

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I RECOMMEND A CHANGE:

1. DOCUMENT NUMBER
MIL-PRF-19500/523B

2. DOCUMENT DATE
990810

3. DOCUMENT TITLE

SEMICONDUCTOR DEVICE, DARLINGTON TRANSISTOR, NPN, SILICON, POWER TYPES 2N6383, 2N6384, 2N6385 JAN, JANTX AND JANTXV

4. NATURE OF CHANGE (Identify paragraph number and include proposed rewrite, if possible. Attach extra sheets as needed.)

5. REASON FOR RECOMMENDATION

6. SUBMITTER

a. NAME (Last, First, Middle initial)

b. ORGANIZATION

c. ADDRESS (Include Zip Code)

d. TELEPHONE (Include Area Code)
COMMERCIAL
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7. DATE SUBMITTED

8. PREPARING ACTIVITY

a. Point of Contact
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